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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Ryuzo OHMUKAI et al.**

Group Art Unit: **2881**

Serial No.: **10/776,341**

Examiner: **Zia R. Hashmi**

Filed: **February 12, 2004**

Confirmation No.: **1765**

For: **ATOMIC LITHOGRAPHY APPARATUS USING ELECTRO-OPTIC  
EFFECT AND METHOD OF MANUFACTURING ATOMIC  
STRUCTURE**

Attorney Docket Number: **042042**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Mail Stop: Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 15, 2005

Sir:

In response to the Office Action dated May 18, 2005, Applicants amend the claims as follows and submit the following remarks.

**Amendments to the claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.